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# TUESDAY, 25<sup>™</sup> April 2023

## **SESSION A: WELCOME AND KEYNOTES**

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09:00	<b>Welcome</b> Erica Lilleodden / Frank Altmann, Fraunhofer IMWS (DE)
09:20	Keynote 1: Process & Materials Characterization for 3D Heterogenous Integration: Opportunities in Smart Metrologies, Data Analytics, & Measurement Standards Gaurang Choksi, Intel Corporation (US)
10:00	Keynote 2: Back-side Power Delivery Network (BSPDN): Innovative scaling booster for 3D heterogeneous integration Anne Jourdain, IMEC (BE)

#### **SESSION B: ADVANCED 3D PACKAGING**

10:40	Hybrid wafer bonding for 3D integration: promises and challenges Viorel Dragoi, EV Group E. Thallner GmbH (AT)
11:00	Failure Analysis Approaches for Test Structures Targeting Wafer-to-Wafer Hybrid Bonding and Backside Power Delivery Development Kristof Jacobs, IMEC (BE)
11:20	X-Ray Device Alteration Using A Scanning X-Ray Microscope William Lo, NVIDIA (US)
11:40	Advances in high-resolution nondestructive defect localization based on recent developments in signal processing Sebastian Brand, Fraunhofer IMWS (DE)
12:00	ESD Targets and Test Methods for High Density Die-to-Die Interfaces Harald Gossner, Intel Cooperation (DE)

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12:20 Lunch Break / Exhibition

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### **SESSION C: NOVEL FAILURE ANALYSIS TECHNIQUES**

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13:40	<b>In Depth Logic Analysis on Digital Designs</b> Fabian Rudau, Robert Bosch GmbH (DE)
14:20	<b>Compatibility of PFIB delayering and nanoprobing for advanced technologies</b> Pascal Gounet, STMicroelectronics (FR)
14:40	Industrial Standards for Integrated Workflows within FA4.0 Christian Hollerith, Infineon Technologies AG (DE)
15:00	Thermal and Failure Analysis of Advanced Sub-Micron Devices Dustin Kendig, Microsanj LLC (US)
15:20	Non-contact sub-micron simultaneous Infrared+Raman microspectroscopy for failure analysis of semiconductor devices Miriam Unger, Photothermal Spectroscopy Corporation GmbH (DE)
15:40	Physical Failure Analysis using Aberration-Corrected S/TEM Rik Otte, NXP Semiconductors (BE)

16:00 Coffee Break / Exhibition

#### **SESSION D: FAILURE ANALYSIS ROAD MAP**

16:40	<b>Die-Level Roadmap Council (DLRC): Isolation Domain</b> William Lo, NVIDIA (US)
16:55	Die-Level Roadmap Council (DLRC): Post-Isolation Domain Eckhard Langer, GlobalFoundries (DE)
17:10	Package Innovation Roadmap Council (PIRC) Yan Li, Intel Corporation (US)
17:25	FA Future Roadmap Council (FAFRC) Nicholas Antoniou, Prime Nano Inc (US)

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- 17:40 Drinks Reception
- 19:00 Social Program: Networking Dinner

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# WEDNESDAY, 26<sup>TH</sup> APRIL 2023

## **SESSION E: AUTOMOTIVE ELECTRONICS - TUTORIAL**

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08:45	<b>Early life failures in automotive electronic</b> Peter Jacob, EM Microelectronic Marin SA (CH)
10:00	Coffee Break / Exhibition SESSION F: AUTOMOTIVE ELECTRONICS
10:40	From embedded safety dominated ECUs towards cyber secure high performance computing systems – an automotive industry's review Andreas Aal, Volkswagen AG (DE)
11:20	Reliability as a key Challenge for future Vehicle Architectures Oliver Senftleben, BMW AG (DE)
11:40	Corrosion on Semiconductor Surfaces – Determination of Ionic Contamination Limits Davina Nienhues, Robert Bosch GmbH (DE)
12:00	Comprehensive Study of Long-Term Reliability of Copper Bonding Wires at Harsh Automotive Conditions Robert Klengel, Fraunhofer IMWS (DE)
12:20	Packaging of MEMS and Sensors Horst Theuss, Infineon Technologies AG (DE)
12:40	<b>Characterization of power semiconductor junctions by</b> <b>combining three-dimensional FIB-SEM imaging and EBIC</b> Heiko Stegmann, Carl Zeiss Microscopy GmbH (DE)

13:00 Lunch Break / Exhibition

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# WEDNESDAY, 26<sup>TH</sup> APRIL 2023

## SESSION G: HARDWARE SECURITY AND COUNTERFEITING

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14:20	Failure Analysis for Physical Assurance Navid Asidi, University of Florida (US)
15:00	<b>Leveraging on FA tools for the recovery of embedded memory</b> <b>data</b> Samuel Chef, Nanyang Technological University (SG)
15:20	No Need for Reverse Engineering – Machine Learning Will Do It for Us Jean Pierre Seifert, TU Berlin (DE)
15:40	<b>E-Beam Probing to attac sub 20nm nodes</b> Jörg Jatzkowski, Fraunhofer IMWS (DE)
16:00	<b>Overcoming hardware attacks with Meridian E: a new approach</b> <b>for nondestructive security validation</b> Neel Leslie, Thermo Fisher Scientific (US)
16:20	High-Throughput Imaging of Semiconductors and Electronic Components by Multi-beam SEM Stephan Nickell, Zeiss MultiSEM GmbH (DE)

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